L Number	Hits	Search Text	DB	Time stamp
_	1150		USPAT;	2004/09/20 11:55
			US-PGPUB;	
			EPO; JPO;	
1	356	//distance ====2 ===============================	DERWENT	2004/00/00 11 50
-	356	((distance near3 sensor) and cassette) and (wafer or substrate)	USPAT; US-PGPUB;	2004/09/20 11:59
		(water or substrace)	EPO; JPO;	
			DERWENT	
-	111	(((distance near3 sensor) and cassette)	USPAT;	2004/09/20 12:00
]		and (wafer or substrate)) and (distance	US-PGPUB;	
		adj sensor)	EPO; JPO;	
	2.5	700 (000) -	DERWENT	
_	75	700/229.ccls.	USPAT;	2004/09/21 11:09
			US-PGPUB; EPO; JPO;	
			DERWENT	
_	o	700/229.ccls. and (distance adj sensor)	USPAT;	2004/09/21 11:09
		, , , , , , , , , , , , , , , , , , , ,	US-PGPUB;	
			EPO; JPO;	
	_		DERWENT	
_	2	700/229.ccls. and (height adj sensor)	USPAT;	2004/09/21 11:19
			US-PGPUB;	
			EPO; JPO; DERWENT	
_	4932	height adj sensor	USPAT;	2004/09/21 11:19
			US-PGPUB;	
			EPO; JPO;	
	,		DERWENT	
-	16825	(height or distance) adj sensor	USPAT;	2004/09/21 11:20
			US-PGPUB;	
			EPO; JPO; DERWENT	
_	425	((height or distance) adj sensor) and	USPAT;	2004/09/21 11:20
		cassette	US-PGPUB;	=====================================
			EPO; JPO;	
			DERWENT	
-	132	(height adj sensor) and cassette	USPAT;	2004/09/21 11:20
			US-PGPUB;	
			EPO; JPO; DERWENT	
_	165	414/674.ccls.	USPAT;	2004/09/23 14:36
			US-PGPUB;	
			EPO; JPO;	
			DERWENT	
-	14	414/674.ccls. and sensor	USPAT;	2004/09/23 16:43
			US-PGPUB; EPO; JPO;	
			DERWENT	
-	37439	distance near3 sensor	USPAT;	2004/09/24 08:28
			US-PGPUB;	
			EPO; JPO;	
_	11200	hoight near? genger	DERWENT	2004/00/04 02 02
-	11390	height near3 sensor	USPAT; US-PGPUB;	2004/09/24 08:29
			EPO; JPO;	
			DERWENT	
-	928		USPAT;	2004/09/24 08:45
		sensor)) and sonic	US-PGPUB;	
			EPO; JPO;	
_	2	//distance near? senson) on theight == 2	DERWENT	2004/00/04 00 00
-	2	<pre>((distance near3 sensor) or (height near3 sensor)) and ultrsonic</pre>	USPAT; US-PGPUB;	2004/09/24 08:29
		Joneson and dicisonic	EPO; JPO;	
			DERWENT	
-	4571	((distance near3 sensor) or (height near3	USPAT;	2004/09/24 08:29
		sensor)) and ultrasonic	US-PGPUB;	
	İ		EPO; JPO;	
L			DERWENT	

	5000		(1 000 / /00 /0
_	5288	((distance near3 sensor) or (height near3 sensor)) and infrared	USPAT; US-PGPUB;	2004/09/24 08:29
			EPO; JPO; DERWENT	
-	174	(((distance near3 sensor) or (height near3	USPAT;	2004/09/24 08:30
		sensor)) and sonic) and platform	US-PGPUB;	
			EPO; JPO; DERWENT	
-	4	(((distance near3 sensor) or (height near3	USPAT;	2004/09/24 08:31
		sensor)) and infrared) and (platform adj	US-PGPUB;	
		height)	EPO; JPO; DERWENT	
-	3	(((distance near3 sensor) or (height near3	USPAT;	2004/09/24 08:36
		sensor)) and ultrasonic) and (platform adj	US-PGPUB;	
		height)	EPO; JPO;	
_	174	(((distance near3 sensor) or (height near3	DERWENT USPAT;	2004/09/24 08:45
		sensor)) and sonic) and platform	US-PGPUB;	2001, 05, 21 00.10
			EPO; JPO;	
_	21	(US-6778874-\$ or US-6401554-\$ or	DERWENT USPAT;	2004/09/24 08:51
		US-6387809-\$ or US-6208909-\$ or	US-PGPUB	2001/03/21 00:31
		US-6206441-\$ or US-6024526-\$ or		
		US-6600418-\$ or US-5868545-\$ or US-6244422-\$ or US-4869639-\$ or		
		US-3672470-\$ or US-6059511-\$ or		
		US-6652015-\$ or US-6571722-\$ or		
	-	US-5201626-\$ or US-6763281-\$ or US-6591160-\$).did. or (US-20020127334-\$ or		
		US-20020032972-\$ or US-20010009076-\$ or		
	1000	US-20010016990-\$).did.		
_	1233	((distance near3 sensor) or (height near3 sensor)) and ((look-up or lookup) adj	USPAT; US-PGPUB;	2004/09/24 08:53
		table)	EPO; JPO;	
	244		DERWENT	0004/00/01 00 =:
_	344	(((distance near3 sensor) or (height near3 sensor)) and ((look-up or lookup) adj	USPAT; US-PGPUB;	2004/09/24 08:54
		table)) and (wafer or substrate)	EPO; JPO;	
			DERWENT	2004/00/04 00 57
-	44	((((distance near3 sensor) or (height near3 sensor)) and ((look-up or lookup)	USPAT; US-PGPUB;	2004/09/24 08:57
		adj table)) and (wafer or substrate)) and	EPO; JPO;	
		platform	DERWENT	0004/00/04 00 00
_	6	(((((distance near3 sensor) or (height near3 sensor)) and ((look-up or lookup)	USPAT; US-PGPUB;	2004/09/24 09:00
		adj table)) and (wafer or substrate)) and	EPO; JPO;	
	_	platform) and deviation	DERWENT	0004/00/00
_	2	((((distance near3 sensor) or (height near3 sensor)) and ((look-up or lookup)	USPAT; US-PGPUB;	2004/09/24 09:00
		adj table)) and (wafer or substrate)) and	EPO; JPO;	
		(deviation near5 table)	DERWENT	